

**MOSEY
PATTERSON &
SHERIDAN, LLP**
ATTORNEYS AT LAW

**RECEIVED
CENTRAL FAX CENTER**

JAN 30 2004

3040 Post Oak Blvd, Suite 1500
Houston, TX 77056-6582
TEL 713.623.4844
FAX 713.623.4846

WWW.MPSH.P.COM

OFFICIAL

FACSIMILE COVER SHEET

DATE: January 30, 2004
FILE NO: AMAT/2592.C6/DSM/LOW K/JW
TO: Examiner: David Nhu
FAX NO: 703-872-9306
PHONE NO: 571-272-1792
COMPANY: USPTO
FROM: Keith M. Tackett
PAGE(S) with cover: 7
ORIGINAL TO FOLLOW? ☐ YES ☒ NO

RULE 312 AMENDMENT AFTER ALLOWANCE

TITLE: Method of Decreasing the K Value in SIOC Layer Deposited by Chemical Vapor Deposition
U.S. SERIAL NO.: 10/632,179
FILING DATE: July 31, 2003
INVENTOR: Gaillard, et al.
EXAMINER: David Nhu
GROUP ART UNIT: 2818
CONFIRMATION NO.: 9827

CONFIDENTIALITY NOTE

The document accompanying this facsimile transmission contains information from the law firm of Moser, Patterson & Sheridan, L.L.P. which is confidential or privileged. The information is intended to be for the use of the individual or entity named on this transmission sheet. If you are not the intended recipient, be aware that any disclosure, copying, distribution or use of the contents of this faxed information is prohibited. If you have received this facsimile in error, please notify us by telephone immediately so that we can arrange for the retrieval of the original documents at no cost to you.

217548_1

